

## Supporting Information

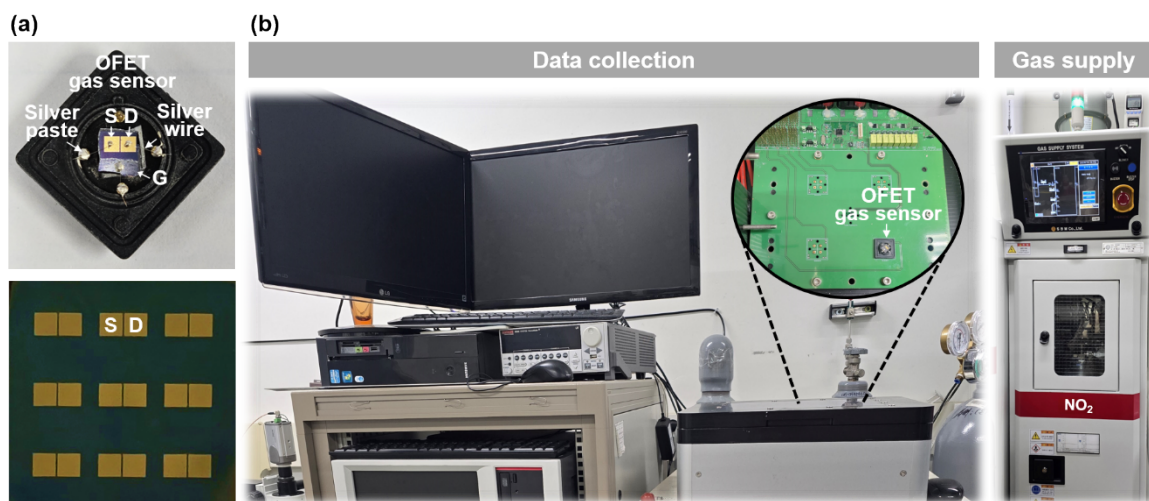
### **Improvement of the chemical and physical gas adsorption ability of poly(3-hexylthiophene) thin films by ultraviolet-ozone exposure**

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**Figure S1.** (a) Photograph of the OTET type gas sensor, (b) Photograph of the gas sensor performance test system.